## Mossbauer and XPS analysis of Fe-SiO<sub>2</sub> and Fe-SiO<sub>2</sub>/SiO<sub>2</sub> granular films

S. Honda\*, T. Shimizu\*, I. Sakamoto\*\*, T. Une\*\*\*, and K. Kawabata\*\*\*

Nanocomposite materials consisting of ultrafine magnetic particles embedded in a matrix which is metallic or insulating have recently attracted great attentions. We have been investigating magnetic and transport properties in Fe-SiO<sub>2</sub> granular films prepared on glass substrates by rf magnetron sputtering. The superparamagnetic nature and the tunneling giant magnetoresistance are observed in the films having Fe volume fractions smaller than 45% [1,2]. In this paper, we report the chemical structures as a function of film thickness for the single layered Fe-SiO<sub>2</sub> films with 44 vol.% Fe and of the thickness of SiO<sub>2</sub> layer for the Fe-SiO<sub>2</sub>/SiO<sub>2</sub> multilayers.

Thicker films show the ferromagnetic hysteresis loops with high magnetization  $M_s$ . However, the magnetization decreases with becoming thinner as shown in Fig.1, and the hysteresis characteristics changes to the superparamagnetism. This behavior is confirmed by the conversion electron Mossbauer spectroscopy (CEMS); in thicker films the ferromagnetic sextet peaks appear, but in thinner films the paramagnetic singlet peak appears overlapping two small peaks (Fig.2a) arising from Fe-O or Fe-Si-O forming the shell of the nanogranule of Fe. In the multilayers of Fe-SiO<sub>2</sub> (10nm)/SiO<sub>2</sub> (x), the magnetization curve shows the superparamagnetic nature, and  $M_s$  decreases with increasing x. In CEMS spectrum, two peaks arising from Fe-O or Fe-Si-O increases also with x as shown in Fig.2, corresponding to the decrease of  $M_s$ .

The XPS spectra indicate also the existence of Fe-O or Fe-Si-O at 711 eV as indicated in Fig.3(a). This peak is very weak in the single layered films, but slightly larger in thinner films than thicker films. In thicker films, the peak intensity increases slightly with approaching the substrates. As shown in Fig.3, the peak of Fe-O or Fe-Si-O becomes remarkable with increasing x in the multilayers. The solid and broken lines indicate the spectra at the Fe-SiO<sub>2</sub> and SiO<sub>2</sub> layers. In (b), the peak of Si shifts to lower energy for the Fe-SiO<sub>2</sub> layer (solid line) comparing to the SiO<sub>2</sub> layer (broken line). Similar energy shift can be observed in the peak of O. These indicate that the oxidation or silicicacidation of Fe occurs by consuming the Si and O of SiO<sub>2</sub>. The intensity ratio of Fe-O or Fe-Si-O and Fe is plotted with the peak intensity of Fe in Fig.4 as a function for the multilayers. In the film of x = 3 nm, the composition modulation can be observed clearly, and the oxidization or silicicacidation occurs selectively at the layer boundaries.

These data indicate that oxygen and silicon are very reactive immediately after the deposition, and so the deposited Fe is partially oxidized or siliconized at near substrate or at surface of  $SiO_2$  layer. Thus,  $M_s$  decreases with decreasing thickness or increasing  $SiO_2$  layer thickness.

<sup>\*</sup> ECS. Fac. of Science and Engineering, Shimane University, Matsue, Shimane 690-8504, Japan \*\* AIST Tsukuba, 1-1-1 Umezono, Tsukuba 305-8568, Japan

<sup>\*\*\*</sup>EPS Engineering, Hiroshima Inst. Tech., 2-1-1 Miyake, Saeki, Hiroshima 731-5193, Japan

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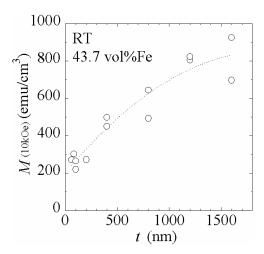
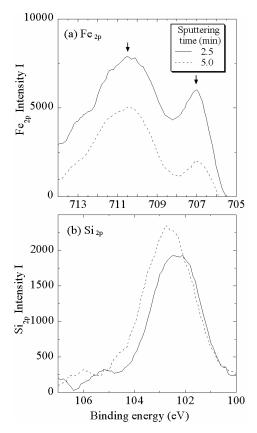


Fig.1 film thickness dependence of magnetization in the Fe-SiO<sub>2</sub> singlelayer films.



 $\label{eq:Fig.3} Fig. 3~XPS~spectrum~of~Fe_{2p},~Si_{2p}\\ in~the~Fe-SiO_2~(10~nm)/~SiO_2~(3~nm)~multilayer.$ 

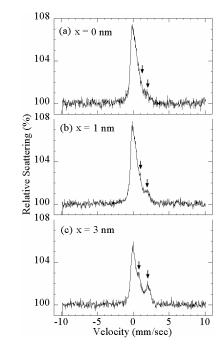


Fig.2 CEMS spectrum of the Fe-SiO $_2$  (10 nm)/ SiO $_2$  (x) multilayers.

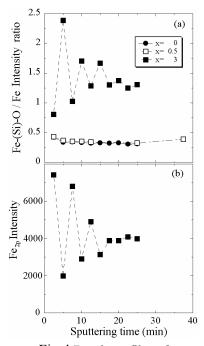


Fig.4 Depth profiles of (a) intensity ratio and (b) intensity for the Fe-SiO<sub>2</sub> (10 nm)/ SiO<sub>2</sub> (x) multilayers.